

## JFW/AF

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Confirmation No. 7179

Takayuki SAITO et al.

Attorney Docket No. 2003 1585A

Serial No. 10/695,826

Group Art Unit 1792

Filed October 30, 2003

Examiner Alexander Markoff

SUBSTRATE PROCESSING APPARATUS

Mail Stop: AF

AND SUBSTRATE PROCESSING METHOD

## **AMENDMENT AFTER FINAL**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated July 11, 2008, please amend the above-identified application as follows.

OK TO ENTER: /AM/

RESPONSE UNDER 37.CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1792

09/18/2008